



Improvement of robotic micromanipulations using chemical functionalisations.

Jérôme Dejeu, Patrick Rougeot, Michaël Gauthier, Wilfrid Boireau

► To cite this version:

Jérôme Dejeu, Patrick Rougeot, Michaël Gauthier, Wilfrid Boireau. Improvement of robotic micromanipulations using chemical functionalisations.. 5th International Precision Assembly Seminar, IPAS'2010., Feb 2010, Chamonix, France. pp.215-221. hal-00459455

HAL Id: hal-00459455

<https://hal.science/hal-00459455>

Submitted on 24 Feb 2010

HAL is a multi-disciplinary open access archive for the deposit and dissemination of scientific research documents, whether they are published or not. The documents may come from teaching and research institutions in France or abroad, or from public or private research centers.

L'archive ouverte pluridisciplinaire **HAL**, est destinée au dépôt et à la diffusion de documents scientifiques de niveau recherche, publiés ou non, émanant des établissements d'enseignement et de recherche français ou étrangers, des laboratoires publics ou privés.

Improvement of Robotic Micromanipulations using Chemical Functionalisations

Jérôme Dejeu, Patrick Rougeot, Michaël Gauthier, Wilfrid Boireau

FEMTO-ST Institute, UMR CNRS 6174 - UFC/ENSMM/UTBM,
24 rue Alain Savary, 25000 Besançon, France
Firstname.surname@femto-st.fr

Abstract: Robotic microhandling is disturbed by the adhesion phenomenon between the micro-object and the grippers. This phenomenon is directly linked to both the object and the gripper surface chemical composition. We propose to control adhesion by using chemical self-assembly monolayer (SAM) on both surfaces. Previous distance-force measurements done with AFM have shown that the liquid pH can be used to modify the adhesion and created repulsive force between the gripper fingers and the micro-object. This paper shows the correlation between the force distance measurements and the micromanipulation tasks using chemically functionalized grippers.

Keywords: Microhandling, Surface functionalisation, Aminosilane, Adhesion, Pull-off forces

1. Introduction

The assembly of microsystems is a great challenge because of the microscopic size of the components. In fact, the major difficulty of micro-assembly comes from the micro-objects' behaviour which depends on surface forces [1-2]. The manipulation of a micro-object requires handling, positioning, and releasing without disturbances of the surface forces such as electrostatic forces, van der Waals forces or capillary forces. The release is the most critical phase which is usually hindered by adhesion.

Several methods have been proposed in the last ten years to improve micromanipulation. The first approach consists in using non-contact manipulation like laser trapping or dielectrophoresis. These manipulation methods are not disturbed by adhesion but the blocking force stays low and thus cannot be easily applied microassembly. The second approach deals with contact manipulation, where the adhesion is directly used for manipulation or strategies, is used to reduce adhesion between end-effectors and objects.

In this article, we propose a new contact handling system based on a chemical control of the surface forces between the object and the gripper. The objective is to control the adhesion force or to create a repulsive force to guarantee a reliable release. Now, the surface properties of a material can be controlled by surface functionalisation in a

liquid by modifying the pH. The charge density on functionalized surfaces is effectively linked to the pH. The microhandling principle based on chemical switching surface is presented in figure 1. The grasping can be done at pH 1 where the surface charge on the gripper and the object induces an attractive force. In order to release the object, the pH is modified to a second value pH 2 where the object charge is changing. The electrostatic force becomes repulsive and the object is released.

This article deals with comparative handling operations performed with different chemical functionalisations at different pH.

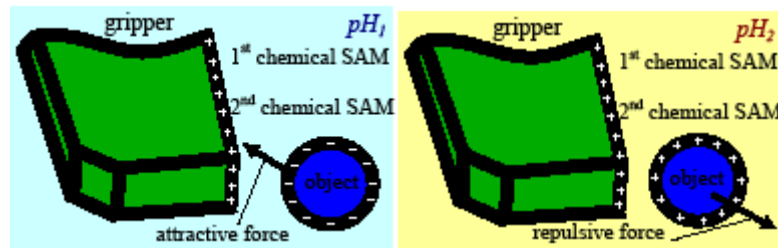


Fig. 1. Principle of the Robotic Microhandling controlled by Chemical Self Assembly Monolayer (SAM)

2. Chemical functionalisation

2.1 General principles

The microhandling method proposed is based on two chemical functions: amine and silica. In one hand, the amino group is in state NH_2 in basic pH and in NH_3^+ in acidic pH. In the other hand, the silica surface charge in water is naturally negative, excepted for very acidic pH, where the surface is weakly positive [3].

The surface functionalisation of both object and gripper can be obtained by different methods. The two most important methods are the molecules grafting on the surface (covalent bond between the substrate and the molecules) or the polyelectrolyte physisorption (polyelectrolyte with positive or negative charges) [4].

We chose to investigate the first method because, firstly, it generates covalent bond between substrate and molecules. These molecules must contain silanol, thiol, azide, allyl or vinyl groups in one extremity. These molecules have to be used in organic solvent such as toluene, acetone, methanol, ethanol, etc. The silanol creates a Si-O-Si bond with the silica substrate while allyl or vinyl generates Si-O-C (or Si-C) bond and the acide groups produce Si-N bond [5]. The second reason is that the layer created by silanisation did not exhibit any signature of degradation when stored in an airtight container for 18 months [6], and was stable up to a temperature near 350°C [7] and

when washed using 1% detergent solution, hot tap water or organic solvents and aqueous acid at room temperature [7].

2.2 Chemical components

The chemical compounds (APTES) used to surface functionalisation are amine functions NH_2 which can be protonated or ionised to NH_3^+ according to pH. In acidic pH, the amine is totally ionised, then the ionisation decreases and is null in basic pH (between pH 9 and 12).

The silanes (APTES), ethanol, sodium chloride (NaCl), sodium hydroxide (NaOH) and hydrochloric acid (HCl), were purchased from Sigma Aldrich.

2.3 Functionalisation mechanisms: Grafted silanes

The self assembled monolayers formation mechanism during silanization process takes place in four steps [6]. The first step is physisorption, in which the silane molecules get physisorbed at the hydrated silicon surface. In the second step, the silane head-groups come close to the substrate hydrolyse, in the presence of the adsorbed water layer on the surface, into highly polar hydroxysilane $-\text{Si}(\text{OH})$. These polar $\text{Si}(\text{OH})$ groups form covalent bonds with the hydroxyl groups on SiO_2 surface (third step). At least, condensation reaction (release of water molecules) appears between silanol functions and neighbor molecules. Self assembly is driven by lipophilic interactions between the linear alkane moieties.

During initial period, only a few molecules will adsorb (by steps 1-3) on the surface and the monolayer will definitely be in a disordered (or liquid) state. However, at long term, the surface coverage eventually reaches the point where a well-ordered and compact (or crystalline) monolayer is obtained (step 4).

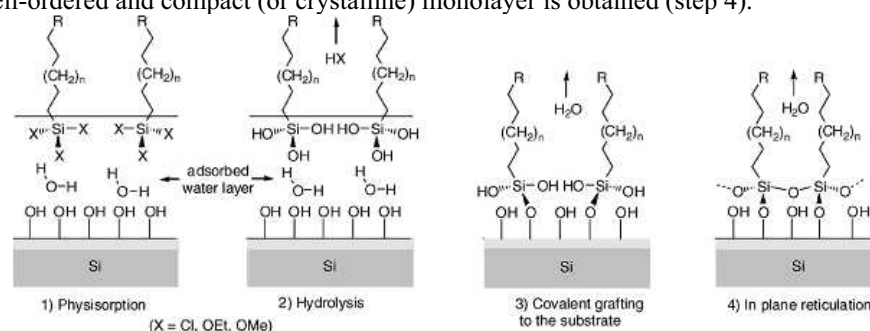


Fig. 2. Steps involved in the mechanism of SAM formation on a hydrated silicon surface [6]

2.4 Characterisation of the functionalised surfaces

Force measurements were performed in order to characterize the functionalisations [8-9]. Force-distance curves were performed using a stand-alone SMENA scanning probe microscope (NT-MDT).

The force measurement performed on this Atomic Force Microscope (AFM) is based on the measurement of the deformation of the AFM cantilever with a laser deflection sensor. The silicon rectangular AFM cantilever, whose stiffness is 0.3N/m, was fixed and the substrate moved vertically. As the applicative objective of this work is to improve reliability of micro-object manipulation, interactions have been studied between a micrometric sphere and a plane. Measurements were in fact performed with a cantilever where a borosilicate sphere ($r_2=5 \mu\text{m}$ radius) was glued (company Novascan Technologies, Ames, USA).

All measurements were done at the driving speed of 200 nm/s to avoid the influence of the hydrodynamic drag forces [10]. For each sample, nine measures were done in different points. The repeatability of all the pull-off and pull-in forces values was better than 10 %.

3. Micromanipulation system

The impact of the functionalisation has been tested on a robotic micro-assembly device composed of a robotic structure, optical microscope, a piezogripper.

Our current robotic micro-assembly device is presented in figure \ref{Fig:Station}. Actuation is divided into two groups which have 3 degrees of freedom (DOF). The first one allows displacement of the substrate, where microparts are placed. Two linear and one rotation DOFs are available in the horizontal plane. The second group is a 'robotic arm', composed of three linear DOFs and two rotation DOFs which enable displacements and rotations of the microgripper.

Moreover, the microgripper is based on a 4 DOFs piezoelectric actuator with silicon finger tips [11]. This gripper induces motions with a great resolution (few tenth of nanometers).

Experiments have been done in wet medium with a functionalised object and :

- end-effectors grafted with APTES and APDMES or
- non-functionalised end-effectors.

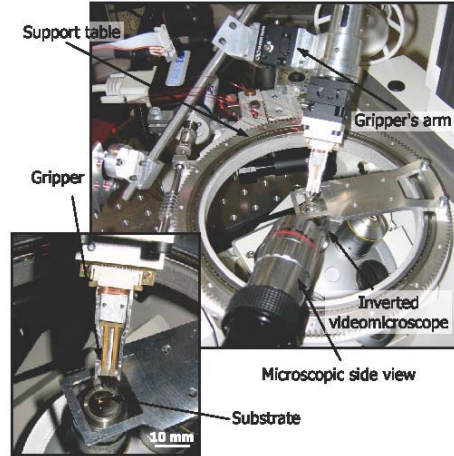


Fig. 3. Microassembly robotic device

Microscopical vision is provided by two videomicroscopes. As the volume above the micromanipulation plane is dedicated to microgripper movement, an inverted microscope LEICA DM-IRBE is used. It enables micro-assembly in liquid medium, whose general interest is synthesized in [2]. A second view for teleoperated operations is given by a side videomicroscope.

4. Micromanipulation results

4.1 Non- functionalized objects

The micromanipulation tasks are often disturbed by the adhesion force between the grippers and the micro-object. Indeed, with the AFM, we measure a pull-off greater than $1 \mu\text{N}$ (Figure 4). This important adhesion force is confirmed by the micromanipulation task with the micromanipulation system. The glass sphere between 1 and $45 \mu\text{m}$ stay attach to the end-effector of the gripper when we open the gripper (Figure 5). The glass spheres are as glued on the end-effector whoever the glass size. Indeed, in the range from 1 to $45 \mu\text{m}$, we observe the same phenomena, no release of the glass when we open the gripper.

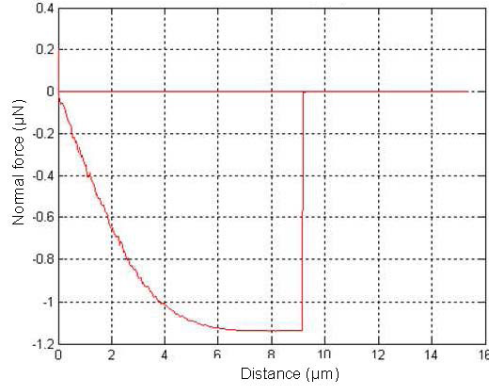


Fig. 4. Force-distance curve between borosilicate cantilever and silica surface (spring constant 0.3 N/m).

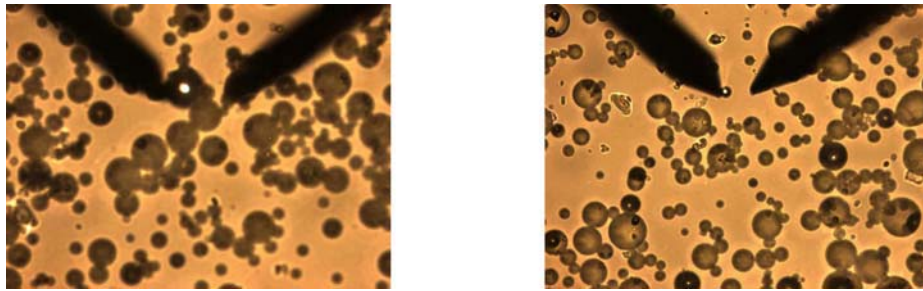


Fig. 5. Glass sphere adhesion during micromanipulation task. Right: small sphere near 3 μm and Left: big sphere near 45 μm

The adhesion can be cancelled by functionalisation of the grippers and the spheres.

4.2 Functionalised objects

In a previous paper, we have shown a repulsion between the surface and cantilever when both are functionalised by an aminosilane and this whatever the pH of the solution. In this paper, illustration of this phenomena is shown in micromanipulation tasks. As the repulsive force has a high interaction distance (typically tens of micrometers) [9], this effect can be used to manipulate the object without contact with the end-effector. Indeed, when the functionalized end-effector is approached near to the functionalized object, the object is moving behind the end-effector (Figure 6). When the ball is caught, the sphere release is easy because of the repulsive force. This release is illustrated Figure 7. In this Figure, we observe that the adhesion does not disturb the release.

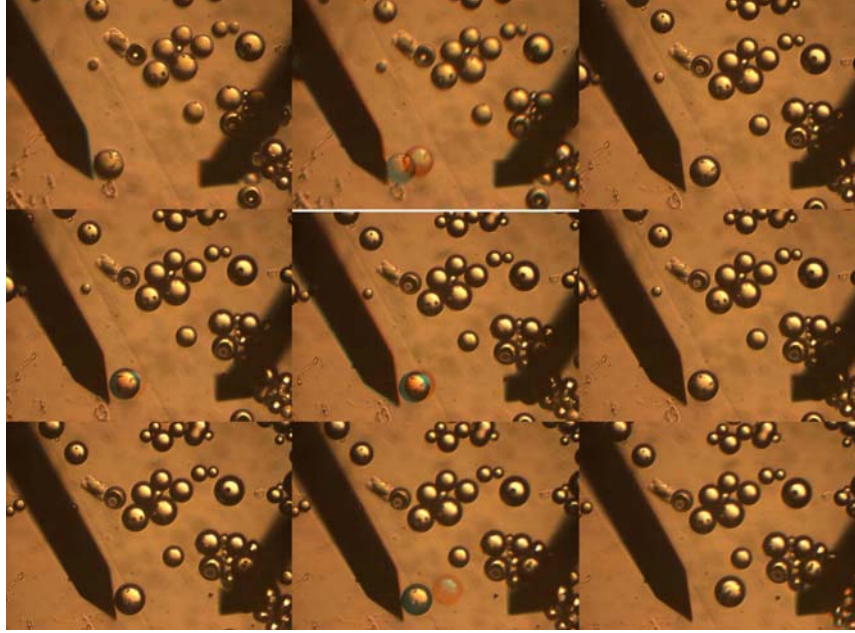


Fig. 6. Repulsion of the functionalised glass sphere when a functionalised SiFit approach to its

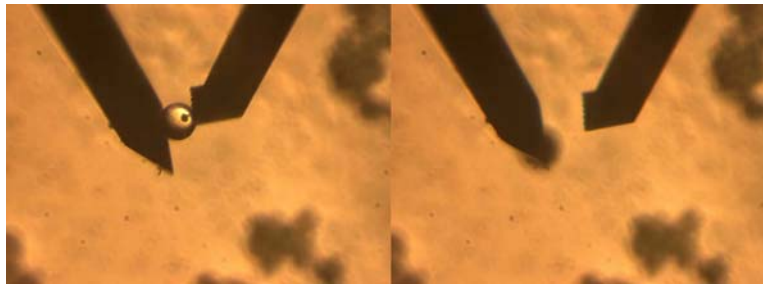


Fig. 7. Release of functionalised glass sphere when the functionalised gripper open

Conclusion

In this paper we have observed the adhesion behaviour between two functionalised surfaces and between two surfaces. We have shown the correlation between the force-distance measurement and the micromanipulation tasks. The liquid medium and the chemical functionalisation can be used to control the surface properties and the micro-object release. As adhesion is the current highest disturbance in micromanipulation, functionalisation is a promising way to improve micro-object manipulation in the future.

Acknowledgement

This work was supported by the EU under HYDROMEL contract NMP2-CT-2006-026622 : Hybrid ultra precision manufacturing process based on positional- and self-assembly for complex micro-products, and by the French National Agency (ANR) under NANOROL contract ANR-07-ROBO-0003: Nanoanalyse for micromanipulate.

References

- [1] Lambert, P: *Capillary Forces in Micro-assembly*. Springer, 2008.
- [2] Gauthier, M., Régnier, S., Rougeot, P., Chaillet, N: Forces analysis for micromanipulations in dry and liquid media. *Journal of Micromechatronics*, 3 (2006) 389-413
- [3] Dove, P., Craven, C.: Surface charge density on silica in alkali and alkaline earth chloride electrolyte solutions. *Geochimica et Cosmochimica Acta*, 69(2005) 4963-4970
- [4] Dejeu, J., Lakard, B., Fievet, P., Lakard, S.: Characterization of charge properties of an ultrafiltration membrane modified by surface grafting of poly(allylamine) hydrochloride. *Journal of Colloid and Interface Science*, 333 (2009) 335-340
- [5] Wang, J., Guo, D., Xia, B., Chao, J., Xiao, S.: Preparation of organic monolayers with azide on porous silicon via *sin* bonds. *Colloids and Surface A : Physicochemical and Engineering Aspects*, 305 (2007) 66-75
- [6] Wasserman, S., Tao, Y., Whitesides, G.: Structure and reactivity of alkylsiloxane monolayers formed by reaction of alkyltrichlorosilanes on silicon substrates. *Langmuir*, 5 (1989) 1074-1087.
- [7] Ulman, A.: *An Introduction to Ultrathin Organic Films From Langmuir-Blogett to Self-Assembly*. Academic Press, 1991.
- [8] Dejeu, J., Rougeot, P., Gauthier, M., Boireau, W.: Adhesions forces controlled by chemical self-assembly and pH, application to robotic microhandling. *ACS Applied Materials & Interfaces*, 1 (2009) 1966-1973.
- [9] Dejeu, J., Rougeot, P., Gauthier, M., Boireau, W.: Robotic submerged microhandling controlled by pH switching. In *Proc. of the IEEE IROS 2009 conference*, St Louis, 2009.
- [10] Vinogradova, O., Yakubov, G.: Dynamic effects on force measurements. 2. lubrication and the atomic force microscope. *Langmuir*, 19 (2003) 1227-1234
- [11] Agnus, J., Hériban, D., Gauthier, M., Pétrini, V.: Silicon end-effectors for microgripping tasks. *Precision Engineering*. 33 (2009) 542-548